



Tool Make & Model

KLA / SPTS - OMEGA fxP

Tool Configuration / Specifications

Plasma Etcher

Rapier Chm

Excluding Synapse Chm

FxP Transport Module

Excluded:

- SMC Thermochiller

TM & VCE dry Pump (QTY 2)

Software Version - 19.8.1.3

Process - Si/Ox/Nit Etch

Chamber System - Rapier Process Module

Handler System - VCE (QTY 2)

RF & Power Rack (QTY 2)

Browse our site at www.moov.co

The information contained in this data sheet is, to our knowledge, accurate. We do not warrant the completeness or accuracy of the information contained herein. Any offer by you to purchase the equipment described in this data sheet shall be subject to the terms and conditions of sale.